



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q64809

Kenji Matsumoto

Appln. No.: 09/873,218

Group Art Unit: 2828

Confirmation No.: 4028

Examiner: Tuan M. NGUYEN

Filed: June 5, 2001

For: SEMICONDUCTOR LASOR FABRICATING METHOD OF THE SAME

REQUEST FOR APPROVAL OF PROPOSED DRAWING CORRECTIONS

Commissioner for Patents
Washington, D.C. 20231

Sir:

Submitted herewith please find five sheets of proposed drawing corrections with the changes indicated in red ink. The Examiner is respectfully requested to acknowledge receipt of the drawing corrections and approve the changes.

Respectfully submitted,

Paul F. Neils
Registration No. 33,102

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Date: December 10, 2002

5# *letter to the Draftsmen*
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